

Abstract Submitted  
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**Growth of ZnSe/BeTe double-barrier quantum-well heterostructure on vicinal Si (100) surfaces by Molecular Beam Epitaxy** EDUARDO MALDONADO, University of Texas at Arlington, KEVIN CLARK, SHWETA BHANDARU, WILEY KIRK — Growth of ZnSe/BeTe on arsenic passivated vicinal Si (100) substrates is reported with the intention to realize a double-barrier quantum-well structure. Such structures grown on GaAs have been reported by other research groups <sup>1</sup> and showed resonant tunneling at room temperature. In our case, the ZnSe/BeTe structure is grown on silicon via a Zn<sub>0.06</sub>Be<sub>0.94</sub>Te buffer layer that is lattice matched to GaAs. The silicon does not play an active role in the RTD behavior; it simply serves as a support layer for the entire structure. Reflection High Energy Electron Diffraction (RHEED) showed an epitaxial growth regime. <sup>1</sup> U.Lunz, M. Keim, G. Reuscher, F. Fischer, K. Schull, A. Waag, and G. Landwehr, J. Appl. Phys. **80**, 6329 (1996)

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